

**AMENDMENT TRANSMITTAL LETTER
Under Small Entity Status**

Attorney Docket No: INK-001

Application Serial Number:
10/765,613

Filing Date:
01/27/2004

Examiner:
Wilson, Lee D.

Group Art Unit:
3723

Invention: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR WAFERS USING ONE OR MORE PIVOTABLE LOAD-AND-UNLOAD CUPS

TO THE COMMISSIONER OF PATENTS AND TRADEMARKS:

Transmitted herewith is an amendment in the above-identified application. The fee has been calculated as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	NO. OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	37	MINUS	38	0	\$25	\$ 0.00
INDEP. CLAIMS	8	MINUS	8	0	\$100	\$ 0.00

Petition is hereby made under 37 CFR 1.136(a) to extend the time for response to the Office Action _____ to and through _____, comprising an extension of the shortened statutory period of:

one month (\$60) three months (\$510)
 two months (\$225) four months (\$795)

TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$ 0.00

Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted.

A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed.

A check in the amount of \$_____ is attached.

Charge \$_____ to Deposit Account _____.

No additional fee is required.

5/16/2007
Date

/thomas h. ham/
Thomas H. Ham
Reg. No. 43,654

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 Applicant(s): In Kwon Jeong Group Art Unit: 3723
Serial No. 10/765,613 Confirmation No. 1365
Filed: January 27, 2004 Examiner: Wilson, Lee D.
10 For: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR
 WAFERS USING ONE OR MORE PIVOTABLE LOAD-AND-UNLOAD
 CUPS

15 Mail Stop AF
 Commissioner for Patents
 P.O. Box 1450
15 Alexandria, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

20 Sir/Madam:

In response to the Final Office Action mailed on March 16, 2007, please consider the following remarks, which begin on page 2 of this paper.

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